



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **Confirmation No. 5731**

Akihisa HONGO et al.

: Attorney Docket No. 2001\_0133A

Serial No. 09/762,582

: Group Art Unit 1753

Filed April 12, 2001

: Examiner Arun Phasge

SUBSTRATE PLATING  
METHOD AND APPARATUS

**Mail Stop: Amendment**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of

June 10, 2005.

The fee of \$450.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

11/14/2005 SZEWDIE1 00000035 09762582

01 FC:1252

450.00 DP

By

David M. Ovedovitz

Registration No. 45,336

Attorney for Applicants

DMO/jmj

Washington, D.C. 20006-1021

Telephone (202) 721-8200

Facsimile (202) 721-8250

November 10, 2005